PATENT

Docket No.: 43889-951

in the united States patent and trademark office

In re Application of

Koji ERIGUCHI, et al.

Serial No.: 09/610,640

Group Art Unit: 1763

Filed: July 05, 2000

Examiner: EVERHART, Caridad

For:

APPARATUS AND METHOD FOR OPTICAL EVALUATION, APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE, METHOD OF CONTROLLING APPARATUS FOR MANUFACTURING SEMICONDUCTOR

DEVICE, AND SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

PRIVED

Commissioner for Patents Washington, DC 20231

JUS 05 2004

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

In accordance with 37 CFR 1.17(p), please charge the fee of \$180.00 to Deposit Account No. 500417.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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INFORMATION DISCLOSURE CITATION IN AN PE APPLICATION				ATTY. DOCKET NO. 43889-951		SE.RIAL NO. 09,'610,640			
APPLICATION IN ADAP E COMMISSION APPLICATION IN ADAP E COMMISSION APPLICATION IN ADAP E COMMISSION IN ADAPT E COMMISSION				APPLICANT Koji ERIGUCHI, et al.					
(PTO-1449)				FILING DATE July 05, 2000	GROUP 1763				
U.S. PATENT DOCUMENTS									
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME		CLASS	SUBCLASS	FILING DATE		
	4,547,074	10/15/85	Hinoda et al.		356	405	5/7/82		
	5,020,910	6/4/91	Dunn et al.		356	328	3/5/90		
	5,877,860	3/2/99	Borden		356	376	5/13/96		
	6,128,084	10/3/00	Nanbu et al.		356	369	6/10/98		
	6,141,103	10/31/00	Pinaton et al.		356	369	3/17/99		
	6,175,416 B1	1/16/01	Maris et al.		356	381	8/24/99		
	5,260,772	11/9/93	Pollak et al.		356	417	7/20/89		
	5,748,318	5/5/98	Maris et al.		356	381	8/6/96		
									
		FOR	EIGN PATE	NT DOCUMEN	TS				
EXAMINER'S INITIALS	PATENT NO.	DATE	СО	UNTRY	CLASS	SUBCLASS		Translation	
	63222473	0/16/00	IMO.		120	00	Yes	No	
	62119422	9/16/88	ЛО		438	80	X	 	
	0768512 A2	5/30/87	JРО БРО		356	43	X		
	6035578	4/16/97	EPO		256	50	X	· .	
	0033376	2/23/85	ЛРО		356	52	X		
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	RECEIVED								
	AUG 05 2004								

EXAMINER DATE CONSIDERED TECHCENTER 2000									

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.